the study of unicellular photosynthetic cells, arachnid systematics, and geochronology and provenance studies. The instrument will allow high quality, high throughput flow with a scope of advanced capability. It will also allow uncoated museum samples to be viewed without damage. *Justification for Duty-Free Entry:* There are no instruments of the same general category manufactured in the United States. Application accepted by Commissioner of Customs: January 13, 2011.

*Docket Number:* 11–005. *Applicant:* National Institute of Standards and Technology, DOC, 325 Broadway, Boulder, Colorado 80305–3328. Instrument: Electron Microscope. Manufacturer: JEOL Ltd., Japan. *Intended Use:* The instrument will be used to study semiconductor, metallic magnetic and nanostructured materials' structure and composition, with nanoscale and atomic level resolution. The required capabilities that the instrument provides include high resolution energy filtered and scanning transmission electron miscroscopy, convergent beam and selected area electron diffraction, and electron energy loss and energy dispersive X-ray spectroscopy. *Justification for Duty-Free Entry:* There are no instruments of the same general category manufactured in the United States. *Application accepted by Commissioner of Customs:* January 14, 2011.

*Docket Number:* 11–006. *Applicant:* University of Vermont, 19 Roosevelt Hwy., Suite 120 Colchester, Vermont 65446. *Instrument:* Electron Microscope. *Manufacturer:* JEOL Ltd., Japan. *Intended Use:* The instrument will be used to investigate advanced glycation end product localization using post-embedding immunoelectron microscopy techniques on thin sections from human cardiac biopsies. Required characteristics of the instrument include 120 kV accelerating voltage, and an electron gun assembly with Cool Beam Illumination System—LaB6 filament standard. *Justification for Duty-Free Entry:* There are no instruments of the same general category manufactured in the United States. *Application accepted by Commissioner of Customs:* January 19, 2011.

*Docket Number:* 11–007. *Applicant:* University of Arkansas, Office of Business Affairs, ADMN 321 Physics Fayetteville, AR 72701. *Instrument:* Electron Microscope. *Manufacturer:* FEI Inc., the Netherlands. *Intended Use:* The instrument will be used to complement the FEI instruments already installed at the facility, and be used to provide high-resolution imaging, spectroscopy, and sample preparation capabilities. The instrument has a unique 5-axis motorized eucentric specimen stage which reads out and displays all 5 axes with an accuracy of 0.01 microns and 0.01 degrees. *Justification for Duty-Free Entry:* There are no instruments of the same general category manufactured in the United States. *Application accepted by Commissioner of Customs:* January 24, 2011.

*Docket Number:* 11–015. *Applicant:* The Regents of the University of California, Lawrence Berkeley National Laboratory, 1 Cyclotron Road, M/S 71R0259, Berkeley, CA 94720. *Instrument:* Electron Microscope. *Manufacturer:* Carl Zeiss SMT, Inc., Germany. *Intended Use:* The instrument will be used to investigate the structure and composition of inorganic, polymer and biological nano-materials. The instrument allows for the employment of transmission microscopy techniques, such as high-resolution imaging and tomography, cryo-imaging, energy-filtered imaging, energy loss spectroscopy and selected-area diffraction. It meets the necessary specifications of the research, including stability of sample stage and image with respect to thermal drift and external vibration, flexibility of stage motions, flexibility of software for signal acquisition and image processing, overall system stability, and ease of use. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* December 7, 2010.

Dated: February 23, 2011.

**Gregory Campbell,**

*Director, IA Subsidies Enforcement Office.*

[FR Doc. 2011–4515 Filed 2–28–11; 8:45 am]

**BILLING CODE 3510–DS–P**

## DEPARTMENT OF COMMERCE

### International Trade Administration

### Application(s) for Duty-Free Entry of Scientific Instruments

Pursuant to Section 6(c) of the Educational, Scientific and Cultural Materials Importation Act of 1966 (Pub. L. 89–651, as amended by Pub. L. 106–36; 80 Stat. 897; 15 CFR part 301), we invite comments on the question of whether instruments of equivalent scientific value, for the purposes for which the instruments shown below are intended to be used, are being manufactured in the United States.

Comments must comply with 15 CFR 301.5(a)(3) and (4) of the regulations and be postmarked on or before March 21, 2011. Address written comments to Statutory Import Programs Staff, Room 3720, U.S. Department of Commerce, Washington, DC 20230. Applications may be examined between 8:30 a.m. and 5 p.m. at the U.S. Department of Commerce in Room 3720.

*Docket Number:* 10–034. *Applicant:* University of Colorado, 12801 E. 17th Ave., RC1 South, Rm 10101, Box 6511, Mailstop 8101, Aurora, CO 80045. *Instrument:* Singer MSM System 300TSA. *Manufacturer:* Singer Instrument Co. Ltd., United Kingdom. *Intended Use:* The instrument will be used to manipulate yeast cells and spores for genetic analysis and construction of strains with particular mutations, pedigree analysis, cell and zygote isolation and cell cycle and cell aging studies. The instrument consists of a micromanipulator device attached to a microscope with a computerized stage that allows the user to keep track of the position. It also has a CCD camera video monitor that reduces the eye strain caused by prolonged peering through microscope objectives. The components of this instrument are specifically designed for work with yeast cells. This instrument is unique because it has a motorized stage, which can be programmed to automatically move to predetermined positions, and the joystick electronic. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* January 12, 2011.

*Docket Number:* 10–077. *Applicant:* University of Chicago LLC, Operators of Argonne National Laboratory, 9700 South Cass Ave., Lemont, IL 60439. *Instrument:* Batch Furnace. *Manufacturer:* NGK Insulators Ltd., Japan. *Intended Use:* The instrument will be used in the synthesis of cathode materials for lithium ion batteries. In particular, the instrument will be applied during the last step of the synthesis—the calcination of the cathode material. The techniques used in calcinations are very dependent on the calcination furnace. This instrument's furnace allows for heating in oxygen flow. The uniformity of heating and oxygen flow is critical to obtain the cathode material because the temperature, together with the oxygen flow, ensures the removal of aqueous residues on the material. The material must be free of water because lithium and water can react and have fatal consequences. This batch furnace includes high distribution of the sample (multiple trays), which allows for faster drying and greater uniformity than a

conventional furnace. This batch furnace also has an oxygen control system that has a 10kg batch size. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* October 14, 2010.

*Docket Number:* 11–001. *Applicant:* Michigan State University, 2555 Engineering Building, Department of Mechanical Engineering, East Lansing, MI 48824–1226. *Instrument:* Diode Pumped High Speed Nd: YAG laser system. *Manufacturer:* Edgewave GmbH, Germany. *Intended Use:* The instrument will be used as a diagnostics equipment to study high temperature combustion occurring in a rotary type engine called a "wave disk engine." The laser will be used to pump a dye laser to generate ultra-violet light which can be used to track chemical species during combustion. The main diagnostics technique will be planar laser fluorescence (PLIF) imaging where the laser light is used to excite target gas species, which can then be imaged using an intensified CCD camera. The main feature of the laser, which is particularly suited for the necessary application, is the beam profile ($M^2$<2) and energy stability over lengthy operation times, which is critical when quantifying combustion species using PLIF over different operation modes. This is the only laser that can do sub 10 ns pulses with all the different specifications. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* December 2, 2010.

*Docket Number:* 11–009. *Applicant:* UChicago Argonne LLC, 9700 South Cass Ave., Lemont, IL 60439–4873. Instrument: Electrode Coater. *Manufacturer:* A–Pro Co., Ltd, South Korea. *Intended Use:* The instrument will be used to aid the development of novel lithium-ion battery materials. The experiments to be conducted with this instrument involve making electrodes for lithium-ion cells with varying amounts and types of active materials in the electrodes and electrolytes. The cells are then subjected to electrochemical performance testing to determine the influence of the active materials under test. The objective is to make lithium-ion cells in a rigid cylindrical (18650) format and compare the results against lithium-ion cells made in a flexible (pouch) format. Key to this research is the ability to make high quality electrodes that can be used in either the 18650 cell or pouch cells. These electrodes are made with an electrode coating machine that needs to be semi-automated and suitable for a laboratory environment, and specially tailored for lithium-ion electrodes. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* January 24, 2011.

*Docket Number:* 11–010. *Applicant:* University of Wisconsin—Madison Materials Science Center, 1509 University Avenue Madison, WI 53706. *Instrument:* Vitrobot Mark IV. *Manufacturer:* FEI Company, the Netherlands. *Intended Use:* The instrument will be used to directly obtain real-space images of native surfactant nanostrutctures in aqueous solutions. Typical materials include samples of a poly(vinyl-alcohol)-derived block copolymer surfactant in aqueous solution, beta-peptide nanorods, and highly ordered lyotropic liquid crystalline aggregates. The experiments to be conducted are to make various combinations of the basic molecules in aqueous solution, and vitrify the samples so they can be placed in an electron microscope to study how the mixtures choose to self-assemble. The specific features that make this instrument unique include the folllowing: instrumental parameters must be computer controlled and enable storing of parameter protocols, including humidity, blotting time and pressure, and equilibration time; mitigation of errors must be derived from the handling of TEM grids including loading, application of sample, plunging, and transfer to storage by automating some of these tasks; and sample blotting must be done automatically with user controlled programmable blot times and pressures. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* January 21, 2011.

*Docket Number:* 11–011. *Applicant:* National Superconducting Cyclotron Laboratory (NSCL) at Michigan State University, 1 Cyclotron Laboratory South Shaw Lane East Lansing, MI 48824–1321. *Instrument:* Differential Plunger Device. *Manufacturer:* Institut fur Kernphysik—Universitat zu koln (Cologne Univ.), Germany. *Intended Use:* The instrument will be used to measure lifetimes of bound and unbound states in rare isotopes with rare isotope beams. Collective motions of nuclei and nuclear reactions will be studied using rare isotope beams. Rare isotopes will be produced using nuclear reactions of stable isotopes accelerated by the existing coupled cyclotron facility. The instrument is specific to the research in level lifetime measurements of rare isotopes. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* January 25, 2011.

*Docket Number:* 11–014. *Applicant:* Purdue University, Herrick Laboratories, 140 S. Martin Jischke Drive, West Lafayette, IN 47907. *Instrument:* Vibration Test System—Shaker in Trunion with Matching Amplifier and Cooling Blower. *Manufacturer:* TIRA, Germany. *Intended Use:* The instrument will be used to look at the dynamic response of flexible structures. It is a general purpose electrodynamic vibration exciter that will facilitate projects involving phenomenon such as near-resonant linear and nonlinear behaviors, structural health monitoring, vibration amplification and attenuation, and energy harvesting. Features of the instrument include its arbitrary excitation angle, large frequency, force, displacement range and spectral output purity. This instrument was unique in that it included the ability to rotate to varying degrees. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* January 7, 2011.

*Docket Number:* 11–017. *Applicant:* UChicago Argonne, LLC, 9700 S. Cass Ave., Lemont, IL 60439. *Instrument:* Electron Guns for Caribu EBIS Charge Breeder. *Manufacturer:* Budker Institute of Nuclear Physics, Russia. *Intended Use:* The instrument will be used to study and optimize parameters of the Electron Beam Ion Source (EBIS) charge breeder for effective further acceleration of rare isotope ion beams by the Argonne Tandem Linear Accelerator System (ATLAS). The experiments conducted will include off-line optimization of EBIS charge breeder efficiency by optimization of ion beam injection and extraction optics. The main requirement to the EBIS charge breeder is its high efficiency and long maintenance free operational period. *Justification for Duty-Free Entry:* There are no instruments of the same general category being manufactured in the United States. *Application accepted by Commissioner of Customs:* February 2, 2011.

February 23, 2011.

**Gregory Campbell,**

*Acting Director, IA Subsidies Enforcement Office.*

[FR Doc. 2011–4517 Filed 2–28–11; 8:45 am]

**BILLING CODE 3510–DS–P**

## DEPARTMENT OF COMMERCE

### International Trade Administration

### Initiation of Five-Year ("Sunset") Review

**AGENCY:** Import Administration, International Trade Administration, Department of Commerce.

**SUMMARY:** In accordance with section 751(c) of the Tariff Act of 1930, as amended ("the Act"), the Department of Commerce ("the Department") is automatically initiating a five-year review ("Sunset Review") of the antidumping duty orders and suspended investigation listed below. The International Trade Commission ("the Commission") is publishing concurrently with this notice its notice of *Institution of Five-Year Review* which covers the same orders.

**DATES:** *Effective Date:* March 1, 2011.

**FOR FURTHER INFORMATION CONTACT:** The Department official identified in the *Initiation of Review* section below at AD/CVD Operations, Import Administration, International Trade Administration, U.S. Department of Commerce, 14th Street and Constitution Avenue, NW., Washington, DC 20230. For information from the Commission contact Mary Messer, Office of Investigations, U.S. International Trade Commission at (202) 205–3193.

**SUPPLEMENTARY INFORMATION:**

#### Background

The Department's procedures for the conduct of Sunset Reviews are set forth in its *Procedures for Conducting Five-Year ("Sunset") Reviews of Antidumping and Countervailing Duty Orders,* 63 FR 13516 (March 20, 1998) and 70 FR 62061 (October 28, 2005). Guidance on methodological or analytical issues relevant to the Department's conduct of Sunset Reviews is set forth in the Department's Policy Bulletin 98.3 —*Policies Regarding the Conduct of Five-Year ("Sunset") Reviews of Antidumping and Countervailing Duty Orders: Policy Bulletin,* 63 FR 18871 (April 16, 1998).

#### Initiation of Review

In accordance with 19 CFR 351.218(c), we are initiating the Sunset Review of the following antidumping duty orders and suspended investigation:

| DOC Case No. | ITC Case No. | Country | Product | Department contact |
|---|---|---|---|---|
| A–427–602 | 731–TA–313 | France | Brass Sheet & Strip (3rd Review) | David Goldberger (202) 482–4136. |
| A–428–602 | 731–TA–317 | Germany | Brass Sheet & Strip (3rd Review) | David Goldberger (202) 482–4136. |
| A–475–601 | 731–TA–314 | Italy | Brass Sheet & Strip (3rd Review) | David Goldberger (202) 482–4136. |
| A–588–704 | 731–TA–379 | Japan | Brass Sheet & Strip (3rd Review) | David Goldberger (202) 482–4136. |
| A–580–839 | 731–TA–825 | South Korea | Polyester Staple Fiber (2nd Review) | Dana Mermelstein (202) 482–1391. |
| A–583–833 | 731–TA–826 | Taiwan | Polyester Staple Fiber (2nd Review) | Dana Mermelstein (202) 482–1391. |
| A–821–811 | 731–TA–856 | Russia | Ammonium Nitrate (2nd Review) | Sally Gannon (202) 482–0162. |

#### Filing Information

As a courtesy, we are making information related to Sunset proceedings, including copies of the pertinent statue and Department's regulations, the Department schedule for Sunset Reviews, a listing of past revocations and continuations, and current service lists, available to the public on the Department's Internet Web site at the following address: "*http://ia.ita.doc.gov/sunset/*." All submissions in these Sunset Reviews must be filed in accordance with the Department's regulations regarding format, translation, service, and certification of documents. These rules can be found at 19 CFR 351.303.

Pursuant to 19 CFR 351.103 (d), the Department will maintain and make available a service list for these proceedings. To facilitate the timely preparation of the service list(s), it is requested that those seeking recognition as interested parties to a proceeding contact the Department in writing within 10 days of the publication of the Notice of Initiation.

Because deadlines in Sunset Reviews can be very short, we urge interested parties to apply for access to proprietary information under administrative protective order ("APO") immediately following publication in the **Federal Register** of this notice of initiation by filing a notice of intent to participate. The Department's regulations on submission of proprietary information and eligibility to receive access to business proprietary information under APO can be found at 19 CFR 351.304–306.

#### Information Required From Interested Parties

Domestic interested parties defined in section 771(9)(C), (D), (E), (F), and (G) of the Act and 19 CFR 351.102(b) wishing to participate in a Sunset Review must respond not later than 15 days after the date of publication in the **Federal Register** of this notice of initiation by filing a notice of intent to participate. The required contents of the notice of intent to participate are set forth at 19 CFR 351.218(d)(1)(ii). In accordance with the Department's regulations, if we do not receive a notice of intent to participate from at least one domestic interested party by the 15-day deadline, the Department will automatically revoke the order without further review. *See* 19 CFR 351.218(d)(1)(iii).

If we receive an order-specific notice of intent to participate from a domestic interested party, the Department's regulations provide that *all parties* wishing to participate in the Sunset Review must file complete substantive responses not later than 30 days after the date of publication in the **Federal Register** of this notice of initiation. The required contents of a substantive response, on an order-specific basis, are set forth at 19 CFR 351.218(d)(3). Note that certain information requirements differ for respondent and domestic parties. Also, note that the Department's information requirements are distinct from the Commission's information requirements. Please consult the Department's regulations for information regarding the Department's conduct of Sunset Reviews.[1] Please consult the Department's regulations at 19 CFR part 351 for definitions of terms and for other general information concerning antidumping and

[1] In comments made on the interim final sunset regulations, a number of parties stated that the proposed five-day period for rebuttals to substantive responses to a notice of initiation was insufficient. This requirement was retained in the final sunset regulations at 19 CFR 351.218(d)(4). As provided in 19 CFR 351.302(b), however, the Department will consider individual requests to extend that five-day deadline based upon a showing of good cause.